

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

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Title of Invention	HIGH-PRESSURE PROCESSING CHAMBER FOR A SEMICONDUCTOR WAFER																																																																																														
<div>Application Number : 10/680783</div> <div>Confirmation Number: 5859</div> <div>First Named Applicant: William Jones</div> <div>Attorney Docket Number:</div> <div>Art Unit:</div> <div>Examiner:</div> <div>Search string: (3623627 or 4426358 or 4574184 or 5374829 or 5474410 or 5879459 or 6048494 or 6062853 or 6089377 or 6406782 or 20010050096).pn</div>																																																																																															
<h3>US Patent Documents</h3> <p>Note: Applicant is not required to submit a paper copy of cited US Patent Documents</p> <table border="1"><thead><tr><th>init</th><th>Cite.No.</th><th>Patent No.</th><th>Date</th><th>Patentee</th><th>Kind</th><th>Class</th><th>Subclass</th></tr></thead><tbody><tr><td></td><td>1</td><td>3623627</td><td>1969-08-22</td><td>Alan S. Bolton</td><td></td><td></td><td></td></tr><tr><td></td><td>2</td><td>4426358</td><td>1984-01-17</td><td>Johansson</td><td></td><td></td><td></td></tr><tr><td></td><td>3</td><td>4574184</td><td>1986-03-04</td><td>Wolf et al.</td><td></td><td></td><td></td></tr><tr><td></td><td>4</td><td>5374829</td><td>1994-12-20</td><td>Sakamoto et al.</td><td></td><td></td><td></td></tr><tr><td></td><td>5</td><td>5474410</td><td>1995-12-12</td><td>Ozawa et al.</td><td></td><td></td><td></td></tr><tr><td></td><td>6</td><td>5879459</td><td>1999-03-09</td><td>Gadgil et al.</td><td></td><td></td><td></td></tr><tr><td></td><td>7</td><td>6048494</td><td>2000-04-11</td><td>Annapragada</td><td></td><td></td><td></td></tr><tr><td></td><td>8</td><td>6062853</td><td>2000-05-16</td><td>Shimazu et al.</td><td></td><td></td><td></td></tr><tr><td></td><td>9</td><td>6089377</td><td>2000-07-18</td><td>Shimazu</td><td></td><td></td><td></td></tr><tr><td></td><td>10</td><td>6406782</td><td>2000-06-18</td><td>Johnson et al.</td><td>B2</td><td></td><td></td></tr></tbody></table>								init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass		1	3623627	1969-08-22	Alan S. Bolton					2	4426358	1984-01-17	Johansson					3	4574184	1986-03-04	Wolf et al.					4	5374829	1994-12-20	Sakamoto et al.					5	5474410	1995-12-12	Ozawa et al.					6	5879459	1999-03-09	Gadgil et al.					7	6048494	2000-04-11	Annapragada					8	6062853	2000-05-16	Shimazu et al.					9	6089377	2000-07-18	Shimazu					10	6406782	2000-06-18	Johnson et al.	B2		
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